

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re U.S. Patent Application of** )  
NAKAMINE et al. )  
**Application Number: To be Assigned** )  
**Filed: Concurrently Herewith** )  
**For: SEMICONDUCTOR DEVICE MANUFACTURING** )  
    **METHOD AND FILM FORMING METHOD** )  
**ATTORNEY DOCKET NO. TSUT.0030** )

**Honorable Assistant Commissioner  
for Patents  
Washington, D.C. 20231**

**INFORMATION DISCLOSURE STATEMENT**

Sir:

Pursuant to 37 C.F.R. §§ 1.56 and 1.97, this Information Disclosure Statement is submitted in the above-identified patent application. A listing of documents to be published on the face of any patent granted from this application is submitted herewith on Form PTO-1449. Any other documents or information submitted for consideration by the Examiner are listed in this paper. A copy of each U.S. and foreign patent, or each publication or portion thereof listed or herein identified, is submitted herewith.

This Information Disclosure Statement is submitted with the initial filing of the application. Accordingly, no fee is due or payable at this time.

The Examiner is requested to acknowledge consideration of the information provided in this paper in accordance with prescribed procedures.

Please charge any additional fees or credit any overpayments in connection with this paper to Deposit Account No. 08-1480.

Respectfully submitted,

Stanley P. Fisher  
Registration Number 24,344

Juan Carlos A. Marquez  
Registration Number 34,072

**REED SMITH LLP**  
3110 Fairview Park Drive  
Suite 1400  
Falls Church, Virginia 22042  
(703) 641-4200

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	APPLICANT NAKAMINE et al.	
	FILING DATE Concurrently Herewith	GROUP

## U.S. Patent Documents

### Foreign Patent Documents

**Other Documents (Including Author, Title, Date Pertinent Pages, Etc.)**

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